

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Takashi IZUTA

Date: March 22, 2004

Serial No.: Not Yet Known

Group Art Unit: ---

Filed: March 22, 2004

Examiner: ---

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

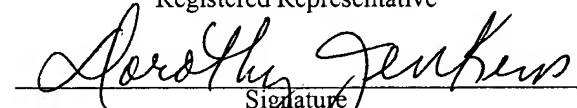
Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail #EV343682993US in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 22, 2004

Dorothy Jenkins

Name of applicant, assignee or
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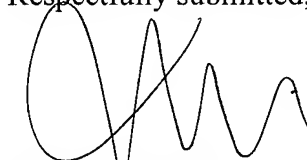


Signature

March 22, 2004

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Respectfully submitted,



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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application Not Yet Known		OFGS File No. P/1596-76			
		Applicant Takashi IZUTA					
		Filing Date March 22, 2004		Group Art Unit ---			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate	
	US-						
	US-						
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
	11-145107	05-1999	Japan			x	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner		Date Considered					
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